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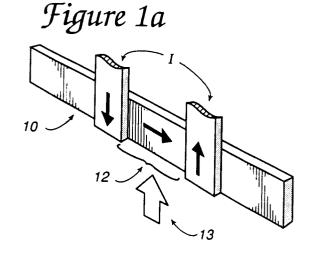
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## [54] Improved magnetoresistive transducer.

The use of a transverse easy axis prevents magnetic domains from forming in the magnetoresistive elements and results in a noise-free device. Various techniques for producing a transverse easy axis include the use of stress, and a magnetostrictive material, during the formation of the MR element to orient the anisotropy of the element transverse to the element, formation of the element in the presence of a magnetic field, high temperature anneal of the element, or any other method of forming the element with a prebiased state.



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The present invention relates to magnetoresistive transducers. More particularly, the present invention relates to an improved magnetoresistive read transducer having a transverse easy axis for biasing and domain stabilization..

Continuing advances in magnetic media technology allow increasing data storage densities. One active area of development is that of reading transducers. As such transducers are made smaller, data densities are increased. Magnetoresistive (MR) thin film technology has provided a particularly promising area of inquiry with regard to producing smaller reading transducers. In such technology, conductive thin films are formed on a substrate using techniques analogous to those of the semiconductor arts.

The present state of the art teaches the use of magnetoresistive elements having an easy axis inplane and along the length of the MR elements. In this configuration, magnetic poles exist at the ends of the stripes and thus result in instabilities, unwanted domain states, and unpredictable response curves. This arrangement is currently in use for the three basic geometries which employ MR technology: single layer structures, soft adjacent layer (SAL) structures where an additional magnetic film is provided to help in biasing the transducer, and dual stripe structures in which both films are magnetoresistive.

Magnetoresistive memory elements have been discussed by Pohm and Comstock, IEEE Trans. Mag. 26, 2529 (1990), which use transverse anisotropy in coupled magnetic films for storing digital information, but not for sensing magnetic fields. However, there is yet to be taught any technique for applying this approach to magnetoresistive transducers, nor is there any recognition that such teachings would be useful in the transducer arts.

The present invention provides an improved magnetoresistive read transducer. In the preferred embodiment of the invention, a magnetoresistive transducer includes at least one magnetoresistive element having a transverse easy axis. In this way, magnetic domains are prevented from forming in the MR elements. Thus, noise-free operation is provided.

In accordance with the present invention, one technique for assuring the MR elements have a transverse easy axis is to take advantage of the magnetostrictive properties of MR elements and form such elements with stress such that the anisotropy of the resulting element produces a transverse easy axis. Other techniques that may be used to orient the easy axis transverse to the MR element may include MR element deposition in the presence of a magnetic field, MR element anneal at a high temperature, or any other method for establishing a prebiased state in the MR element.

Fig. 1a is an elevation of a single-stripe read structure with current leads transverse to a magnetoresistive element according to the present invention:

Fig. 1b is an elevation of a single-stripe read structure with current leads along the magnetoresistive element according to the present invention:

Fig. 1c is an elevation of a soft adjacent layer (SAL) read structure according to the present invention:

Fig. 1d is an elevation of a dual-stripe read structure according to the present invention;

Fig. 2a is an elevation showing magnetization distribution in a single layer structure with no media field applied;

Fig. 2b is an elevation showing magnetization distribution in a bilayer structure with no media field applied;

Fig. 3 is a response curve of a dual-stripe magnetoresistive read head with transverse anisotropy;

Fig. 4 is a response curve showing behavior of one stripe of a dual-stripe magnetoresistive read head plotting a larger field than is shown in Fig. 3: and

Fig. 5 is a graph plotting the dependence of the output resistance swing as the bias current is varied for a dual-stripe magnetoresistive head having transverse anisotropy and in which data is shown for both increasing and decreasing currents

The present invention is best understood by referring to the Drawings in connection with review of this Description. The present invention provides a magnetoresistive (MR) read head in which the easy axis of the magnetic films that form the read element are defined in such as way as to provide biasing and stabilization of the domain structure. The preferred embodiment of the invention is described herein with regard to three geometries of MR read heads: a single layer structure (as shown in Figs 1a and 1b), a soft adjacent layer (SAL) structure in which an additional magnetic film is provided to improve biasing (as shown in Fig. 1c), and a dual-stripe structure in which both films are magnetoresistive elements (as shown in Fig. 1d).

The present invention provides a structure for all three transducer geometries having the easy axis of the magnetization in-plane but transverse to the length of the elements. In Fig. 1a, a single-stripe read structure is shown having current leads transverse to the MR element. In the Fig., a magnetoresistive element 10 is shown having an active area 12 in the presence of a media field (indicated by the arrow 13). Current leads 'I' are indicated by the arrows which point in the direction of current flow.

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In Fig. 1b, a single-stripe read structure is shown having current leads along the MR element. In the Fig., a magnetoresistive element 15 is shown having an active area 16 in the presence of a media field (indicated by the arrow 17). Current leads 'I' are indicated by the arrows which point in the direction of current flow.

In Fig. 1c, a soft adjacent layer structure is shown having current leads transverse to the MR element. In the Fig., a magnetoresistive element 20 is shown having an active area 22 in the presence of a media field (indicated by the arrow 23). A soft magnetic film 21 is shown and is included to help in biasing the MR element. Current leads 'I' are indicated by the arrows which point in the direction of current flow.

In Fig. 1d, a dual-stripe read structure is shown having current leads transverse to the MR element. In the Fig., magnetoresistive elements 25,26 are shown having an active area 27 in the presence of a media field (indicated by the arrow 28). Current leads 'I' are indicated by the arrows which point in the direction of current flow.

The distribution of magnetization in a single layer film with no field applied is shown in Fig. 2a. In the Fig., a magnetoresistive element 30 is shown having a transverse easy axis orientation 31. Magnetization direction 32 is as indicated by the arrows on the MR element 30.

In Fig. 2b, the distribution of magnetization for a bilayer film with no field applied is shown. In Fig. 2b., dual magnetoresistive stripes 35,36 are shown having a transverse easy axis orientation 37,38. Magnetization direction 39,40 is as indicated by the arrows on the respective MR elements 35,36.

In Figs. 2a and 2b, the magnetization at the center of the MR element is oriented transversely because of the easy axis orientation in the magnetic film. At the edges of the device, the magnetization is oriented along the element because of the demagnetizing fields associated with the edge of the film. Adequate signal response is maintained by using structures with small heights of several micrometers or less such that only the center of the MR element is oriented transverse to the element.

It should be noted that bilayer transducer structures require less material anisotropy to overcome the demagnetizing fields associated with the edge because of the strong magnetostatic coupling between the two films. In bilayer transducer structures, the sense current that flows in the device provides a field that is also oriented in the transverse direction. In a dual-stripe transducer structure, the field is in opposite directions in each of the MR elements. In SAL structures, the current only flows in one element, but the strong coupling between the films results in a rotation of the mag-

netization that is also in opposite directions in each of the elements. The current can be used to initialize the device into the magnetic state shown in Fig. 2b because the field from the current and the easy axis are in the same direction.

The easy axis of the MR elements can be defined by using a variety of standard methods. For example, deposition of the MR element in a field or annealing the film at high temperature in a field are two possible methods. An additional method, is to use magnetic films with magnetostriction such that when fabricated, the stresses produced in the transducer structure from the formation of the air bearing surface result in a transverse easy axis. The specific features of the read head, such as the presence of magnetic shields, the magnetoresistive element shape, and the lead configuration are a matter of choice.

The mechanism by which the MR element is initialized into the stable state is a result of the sense current. The field from the sense current is along the easy axis of the film and is in opposite direction in either MR element. These directions favor the antiparallel state shown in Fig. 2b and, as a result, the device can be initialized into this state by the current. This does not occur in a conventional head because the desired single domain state is transverse to the sense current and therefore the current does not couple to it.

One important aspect of the present invention is that magnetic domains are prevented from forming in the MR elements, resulting in noise free operation. In the present invention, MR read transducers were fabricated with transverse anisotropy. An external field was used to excite the transducer. The output of these transducers for four field cycles is plotted on Fig. 3. The reproducibility of the response is an indication of the lack of magnetic domain walls in the active area of the device.

If a larger field is used to excite the device, then the response is as shown in Fig. 4. The large jumps that occur at high fields indicate that when a large enough field is applied, the device can be made to switch to another state.

However, on return to a lower field, the device initializes itself again into a stable state. This ability to re-initialize into a stable, noise free state is important when a read transducer is designed that includes an attached write transducer because of the large fields that can be present near the write transducer.

The strongly linear region that is shown in Figs. 3 and 4 for low fields is also a result of the transverse anisotropy. The linearity can be shown from a micromagnetic model to arise from the cancellation of the longitudinal shape anisotropy by the transverse anisotropy. This linearity is especially important for SAL devices because, with cur-

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rent biasing, the device response is nonlinear.

An additional advantage of the invention is that the bias of the device is set primarily through the action of the anisotropy and the shape of the device, and only set secondarily by the current. This feature is shown in Fig. 5, where the behavior as a function of the bias current is plotted. The lack of variation in total resistance swing as the bias current is varied is a result of the transverse anisotropy producing a prebiased state in the MR elements. This makes it easier to set the current level to achieve maximum signal without strongly affecting the bias point of the device. In addition, the output remains constant as the current is cycled from low current to high current. This aspect of the invention is important to assure that the head returns to the same state when turned on, especially if this is done after each write cycle.

The ability to bias the MR element by transverse anisotropy is important for the single layer devices shown in Figs. 1a and 1b. These devices do not need an extra layer of magnetic material or an extra conductor to provide a bias field. This reduces the number of films that need to be deposited to fabricate the device and allows narrower gaps in the active region to be achieved.

Magnetoresistive elements having thicker films can be used with the present invention. With conventional elements, biasing thick films is a problem because of the larger shape demagnetizing fields produced by the larger magnetization. The transverse easy axis of the present invention helps to overcome the shape effects allowing the device to be biased. Thicker films have, in Principle, less noise because the texture of the surface plays less of a role in determining their magnetic behavior.

The stabilization of the MR elements is achieved without additional processing. For example, establishing a preferred direction along the easy axis for elements having the easy axis along the length of the elements has often been done using exchange-coupled layers. This requires additional processing and involves maintaining precise control of the materials. The present invention establishes the easy axis direction by controlling only the material properties of the MR element itself.

## Claims

- A magnetoresistive transducer, comprising:
   at least one magnetoresistive element
   (15), said element having a transverse easy
   axis, whereby noise-free transducer operation
   is provided.
- 2. The transducer of claim 1, said magnetoresistive element having a height of several micrometers or less such that the magnetization

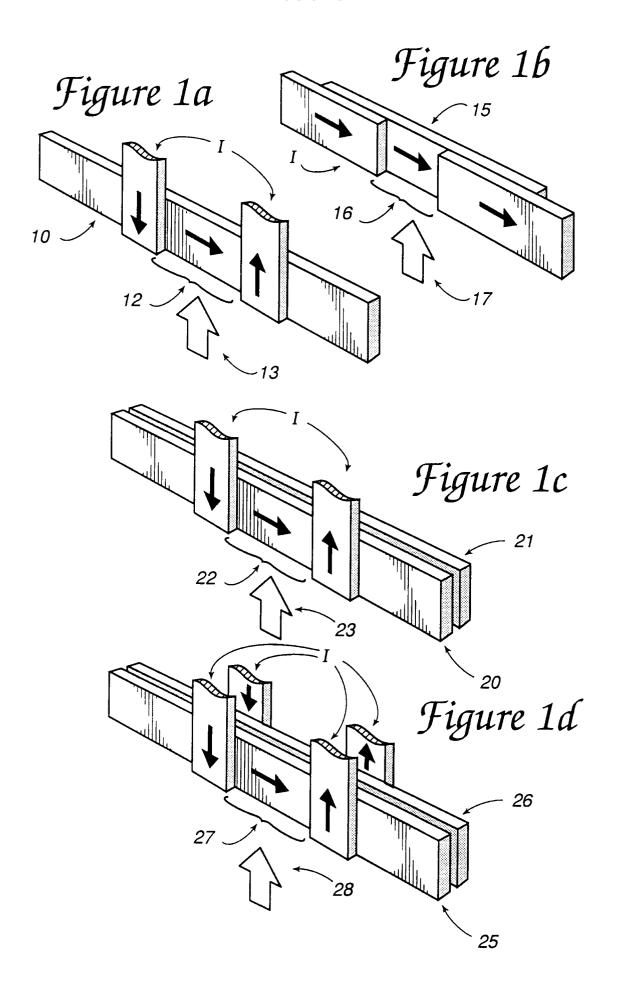
at the center of the element is oriented transverse to the element, the element thus having anisotropy oriented to produce a magnetization transverse to said element.

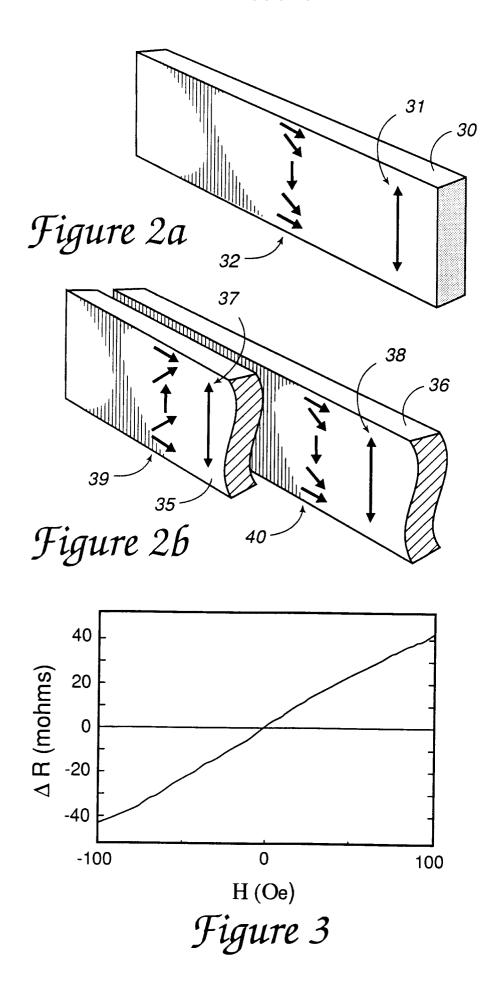
- The transducer of either of claims 1 or 2, wherein said magnetization is produced by magnetostriction introduced into the element.
- 4. The transducer of either of claims 1 or 2, wherein said magnetization is produced by forming said element in the presence of a magnetic field.
- **5.** The transducer of either of claims 1 or 2, wherein said magnetization is produced by annealing said element at a high temperature.
  - **6.** The transducer of any of claims 1 to 5, wherein said magnetization is produced by establishing a prebiased state in said element.
  - 7. A method for making a magnetoresistive element in accordance with any of claims 1 to 6, comprising the steps of:

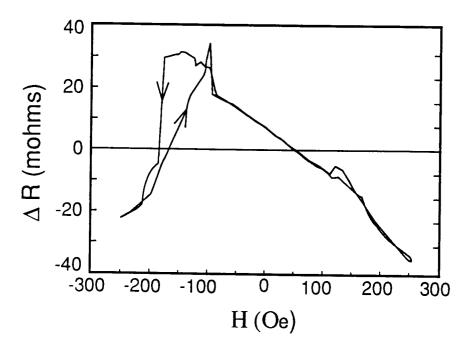
forming a magnetoresistive element having a height of several micrometers or less such that the magnetization at the center of the element is oriented transverse to the element, the element thus having anisotropy oriented to produce a magnetization transverse to said element.

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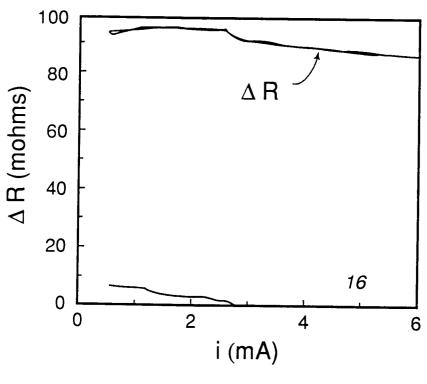


Figure 5